

1746

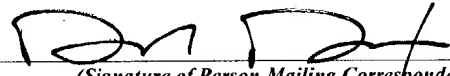
CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8) Addressee(s): YOUNG HOON PARK	Docket No. YPL-0019
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Serial No. 09/848,533	Filing Date MAY 03, 2001	Examiner MARKOFF, A.	Group Art Unit 1746
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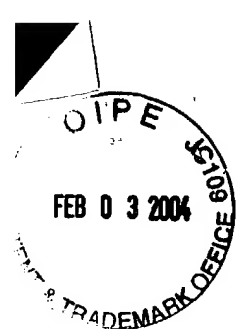
Invention: **ATOMIC LAYER DEPOSITION (ALD) THIN FILM DEPOSITION EQUIPMENT HAVING CLEANING APPARATUS ADN CLEANING METHOD**

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I hereby certify that this **REPLY TO NON-FINAL OFFICE ACTION UNDER 37 CFR 1.111 w/AMENDMENT**
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is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
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APPLICANT: YOUNG HOON PARK)
)Group Art No.: 1746
SERIAL NO.: 09/848,533)
)Examiner: Markoff, A.
FILING DATE: May 03, 2001)
)Conf. No. 7524
FOR: ATOMIC LAYER DEPOSITION (ALD))
 THIN FILM DEPOSITION EQUIPMENT)
 HAVING CLEANING APPARATUS AND)
 CLEANING METHOD)

**REPLY TO NON-FINAL OFFICE ACTION
UNDER 37 C.F.R. §1.111, WITH AMENDMENT**

The Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir or Madam:

In response to an Office Action of November 18, 2003, please enter and consider the following:

Amendment to the Claims, beginning on page 2 of this paper; and
Remarks, beginning on page 5 of this paper.